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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

31040 U.S. PTO
10/042573
01/09/02
30-917

APPL NUM 10042573	FILING DATE 01/09/2002	CLASS 1233	SUBCLASS 692	GAU 2823 1746	GROUP ART UNIT Estrad-	EXAMINER
**APPLICANTS: Chen Kei-Wei; Wei Kuo-Hsiu; Lin Yu-Ku; Wang Ting-Chun; Wang Ying-Lang; Chang Shih-Tzung;						
**CONTINUING DATA VERIFIED:						
** FOREIGN APPLICATIONS VERIFIED:						
PG-PUB <input checked="" type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/> RESCIND <input type="checkbox"/>						
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO TS01-796/786		
TITLE : Removal of sion residue after CMP						

U.S. DEPT. OF COM. / PAT. & TM. PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
ISSUE FEE		DRAWING	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner PREPARED FOR ISSUE Application Examiner	
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